



PATENT  
ATTORNEY DOCKET: 46884-5345

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
Satoshi MATSUMOTO et al. ) Confirmation No.: 8192  
Application No.: 10/518,392 ) Group Art Unit: 2859  
Filed: July 25, 2005 ) Examiner: Gail K. Verbitsky  
For: LASER PROCESSING APPARATUS, )  
LASER PROCESSING )  
TEMPERATURE MEASURING )  
APPARATUS, LASER )  
PROCESSING METHOD, AND )  
LASER PROCESSING )  
TEMPERATURE MEASURING )  
METHOD )

Commissioner for Patents  
U.S. Patent and Trademark Office  
**Customer Window, Mail Stop Amendment**  
Alexandria, VA 22314

Sir:

**AMENDMENT**

In response to the Office Action dated July 11, 2007, the period for response to which extends through January 11, 2008 by the concurrently-filed petition for a three-month extension of time and corresponding fee payment, please amend the above-identified application as follows.